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Client/Matter/Tkpr:	070602-0406-8565	Original to Follow by Mail:	No
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Re: U.S. Patent Application No. 10/692,704
For: METHOD AND SYSTEM FOR MEASURING DIFFERENTIAL SCATTERING OF
LIGHT OFF OF SAMPLE SURFACES
Inventor: Brian B. Jones
Attorney Docket: 070602-0406

Message:

ORC 376410-1.070602.0406

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U.S. practice conducted through McDermott Will & Emery LLP.
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PAGE 1/2 * RCVD AT 11/10/2005 6:22:37 PM [Eastern Standard Time] * SVR:USPTO-EFXXRF-6/24 * DNIS:2738300 * CSID:949 851 9348 * DURATION (mm-ss):00-40

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PATENT

Docket No.: 070602-0406

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 31824
:
Brian B. Jones : Confirmation Number: 9806
:
Application No.: 10/692,704 : Group Art Unit: 2877
:
Filed: October 24, 2003 : Examiner: Amanda H. Merlino
:
For: METHOD AND SYSTEM FOR :
MEASURING DIFFERENTIAL :
SCATTERING OF LIGHT OFF OF :
SAMPLE SURFACES :

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SECOND STATUS INQUIRY

Sir:

A Status Inquiry was filed on May 2, 2005, in the above-identified application. To date, Applicant has not received a response from the Patent Office indicating the status of the application. In this regard, more than twenty-four months have elapsed since the filing date and no Office Action has been received by Applicant. Accordingly, Applicant again respectfully requests that the undersigned attorney be informed of the status of the referenced application.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



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